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PATENT  
930055-2031

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Tetsuo YAMADA, et al.  
Serial No. : 10/518,704  
For : THIN FILM PIEZOELECTRIC RESONATOR, THIN  
FILM PIEZOELECTRIC DEVICE, AND  
MANUFACTURING METHOD THEREOF (As Amended)  
Filing Date : December 17, 2004  
Examiner : Mark Osborne Budd  
Group Art Unit : 2834  
Confirmation No. : 5674

745 Fifth Avenue  
New York, NY 10151  
(212) 588-0800

I hereby certify that this correspondence is being deposited with  
the United States Postal Service as first class mail in an envelope  
addressed to: Mail Stop Amendment, Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April  
30 2007.

Ronald R. Santucci, Reg. No. 28,988  
(Name of Applicant, Assignee or Registered Representative)

Signature

April 30 2007

Date of Signature

AMENDMENT UNDER 37 C.F.R. 121

AF  
Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action dated March 1, 2007, setting a three-month  
period for response ending June 1, 2007, Applicants respectfully request that the application be  
further amended as follows: